Receipt date: 04/21/2009 10594949 - GAU: 2893

INFORMATION DISCLOSURE CITATION			Attorney Docket No.: 46884-5520				Serial No.: 10/594,949			
(Use several sheets if necessary)			Applicants Takeshi SAKAMOTO et al.				Page 1 of 1			
PTO Form 1449			Filing Date: June 21, 2007			Group Art Unit: 2893				
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Examiner: Initial if	reference considered, whether or not nformance and not considered. Inclu	citation is in con	formance wit	th MPEP	609; draw	line throug applicant.	gh citat	ion if		